

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 10/039,456
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Inventor Ying Huang et al.
Assignee Micron Technology, Inc.
Priority Group Art Unit 2829
Priority Examiner S.B. Geyer
Attorney's Docket No. MI22-2347
Title: An Improved Method, Structure and Process Flow to Reduce Line-Line
Capacitance with Low-K Material

PRELIMINARY AMENDMENT

To: Mail Stop Patent Application
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Sir:

This is a preliminary amendment accompanying a Request for Continuation Application for the above-entitled patent application. Prior to examining the application, please enter the following amendments.

AMENDMENTS

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.